



**RESPONSE UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE REQUESTED  
EXAMINING GROUP 2823**

**PATENT**  
Customer No. 22,852  
Attorney Docket No. 04329.2622

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:	)	
	)	
Gaku MINAMIHABA, et al.	)	Group Art Unit: 2823
	)	
Serial No.: 09/932,943	)	Examiner: Lee, Hsien Ming
	)	
Filed: August 21, 2001	)	
	)	
For: SLURRY FOR CHEMICAL	)	
MECHANICAL POLISHING AND	)	
METHOD OF MANUFACTURING	)	
SEMICONDUCTOR DEVICE	)	

**Mail Stop AF**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**REQUEST FOR RECONSIDERATION AFTER FINAL**

In reply to the Final Office Action mailed September 16, 2004, with a period for response extending through February 16, 2005 by the attached Petition for Extension of Time of Two Months and requisite fee payment, Applicants request the Examiner's reconsideration in view of the remarks that follow:

**Remarks begin on page 2 of this paper.**